

Notice of References Cited	Application/Control No. 10/564,837		Applicant(s)/Patent Under Reexamination HONGO ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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	D	US-			
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	F	US-			
	G	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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	V	Tateishi et al. "Scrapie Removal using Planova Removal Filters", Biological (2001) 29, page 17-25
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.